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Simultaneous measurement of vibration and parameters of a semiconductor laser using self-mixing interferometry

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Simultaneous measurement of vibration and parameters of a semiconductor laser using self-mixing interferometry

Abstract

Laser diode (LD)-based self-mixing interferometry (SMI) is a promising technique for noncontact sensing and its instrumentation. According to the well-known Lang-Kobayashi equations, an SMI waveform is shaped by multiple parameters, including linewidth enhancement factor (denoted as α), optical feedback level factor (denoted as C), and the movement of the external cavity of an LD. This paper presents a new algorithm for simultaneously retrieving the multiple parameters from a piece of SMI signal. First, a set of linear equations is derived based on the existing SMI model. By careful selection of data samples, the linear equations can be made independent and used to determine a set of variables, and thus the values of α and C , as well as the reconstruction coefficients of the external movement. The work in this paper lifts the restrictions existing in SMI-based sensing methods, such as prerequisite knowledge of either α and C or vibration information of an external target. Simulations and experiments are conducted to verify the proposed algorithm.

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Simultaneous measurement of vibration and parameters of a semiconductor laser using self-mixing interferometry

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A laser diode (LD) based self-mixing interferometry (SMI) is a promising technique for non-contact sensing and its instrumentation. According to the well-known Lang-Kobayashi (L-K) equations, an SMI waveform is shaped by multiple parameters, including linewidth enhancement factor (denoted as α), optical feedback level factor (denoted as C) and the movement of the external cavity of an LD. This paper presents a new algorithm for simultaneously retrieving the multiple parameters from a piece of SMI signal. Firstly, a set of linear equations is derived based on the existing SMI model. By careful selection of data samples, the linear equations can be made independent and used to determine a set of variables, and thus the values of α and C , as well as the reconstruction coefficients of the external movement. The work in this paper lifts the restrictions existing in SMI based sensing methods, e.g. requiring pre-requisite knowledge of either α and C or vibration information of an external target. Simulations and experiments are conducted to verify the proposed algorithm. © 2014 Optical Society of America

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1. Introduction

Self-mixing interferometry (SMI) has been an active area of research as an enabling technique for non-contact sensing and its instrumentation in recent decades. The basic structure of an SMI consists of a laser diode (LD), a focusing lens and a vibrating target which forms the external cavity of the LD. When a portion of light emitted by the LD is backscattered or reflected by the vibrating external target and re-enters the laser cavity, a modulated lasing field will be formed in both amplitude and phase. The modulated laser power, detected by a photodiode (PD) packaged at the rear facet of LD, is called an SMI signal. It carries the information of the external target vibration and the parameters related to the LD. Generally, there are two classes of applications for SMI based sensing: 1) estimation of parameters associated with an LD; and 2) measurement of the metrological quantities of the external target.

Use of SMI for measuring LD parameters mainly focuses on the linewidth enhancement factor and the optical feedback level [1-8]. The linewidth enhancement factor, also called the alpha factor (α - parameter), is one of fundamental parameters in the LDs as it characterizes the LD linewidth, the chirp, the injection lock range and the response to optical feedback. The optical feedback level, denoted as C , describes the coupling strength of the optical feedback in the LD cavity and is utilized for classifying

different optical feedback regimes, namely weak feedback regime (where $0 < C < 1$), moderate feedback regime (where $1 < C < 4.6$) and strong feedback regime (where $C > 4.6$). The existing methods in this application class have the following limitations: 1) The SMI system has to operate in a certain feedback range, e.g. the methods in [2, 4, 8] are valid for weak feedback regime ($0 < C < 1$) and the method in [1] can be used for moderate regime ($1 < C < 3$); 2) a prior knowledge is required on the movement of the external cavity [2, 4, 8], e.g., the movement must be in the form of a simple harmonic vibration; 3) complex signal processing techniques are required such as phase unwrapping (PUM) in [5, 7] and data-to-model fitting algorithms in [2, 4, 8]. These requirements bring a certain difficulty to implement practical systems. Therefore, it is of importance to have a method that can be used without the above restrictions on the optical feedback regime and the external target vibration.

Another class of applications is on the measurement of a target movement. The resolution of SMI based measurement using the fringe counting method is half-wavelength. The resolution can be greatly improved by sophisticated signal pre-processing, fringe sub-division and SMI model-based reconstruction. However, all existing approaches suffer from some restrictions which may degrade the performance. In 1995, a fringe counting method [9] was developed based on the theory that each fringe on an SMI signal represents a half-wavelength shift of a vibrating target. The method is easy to implement but the resolution is only a

half-wavelength for vibration measurement. In order to improve the accuracy of the vibration measurement, different methods have been developed [5, 10-15], but all valid to a certain range of C . The methods in [9, 12, 14] can only be applied in moderate regime where $1 < C < 4.6$ and the method in [11] is only valid in weak regime where $0 < C < 1$. The method in [15] can work in both weak and moderate feedback regimes. At the weak feedback, the fringe counting (with half wavelength resolution) is used for vibration detection. At the moderate feedback, similar to [14], each SMI fringe is treated as a linear sawtooth shape, ignoring the influence of parameters C and α on fringe shape, which causes detection errors on vibration. Besides, the accurate values for α and C are pre-required by methods [5, 9, 10], which is not always possible in practice. Moreover, computationally extensive operations are also required by these methods, such as PUM [5, 10, 12], interpretation of interfringe of SMI signal [11] and Evolutionary algorithm [13], which can degrade the efficiency of these approaches.

The purpose of this paper is to present a novel algorithm that is able to simultaneously retrieve vibration information and LD related parameters, thus lifting the restrictions on all existing techniques in literature. The proposed method is also characterized by simple computation, thus making it easy to be implemented in practice.

2. Theory and algorithm

A. SMI model

The basic theoretical model for an SMI system is shown as follows [2].

$$p(t) = p_0 [1 + m \cdot g(t)] \quad (1)$$

$$g(t) = \cos(\phi_F(t)) \quad (2)$$

$$\phi_0(t) = \phi_F(t) + C \cdot \sin[\phi_F(t) + \arctan(\alpha)] \quad (3)$$

$$\phi_0(t) = \frac{4\pi}{\lambda_0} [L_0 + \Delta L(t)] \quad (4)$$

The physical meanings of the symbols in the above model are summarized in table 1.

Above SMI model shows that an SMI signal, that is $g(t)$, carries the information of the external cavity movement and the parameters α and C . In the following, we aim to simultaneously retrieve all of these parameters. Note that $\phi_0(t)$ can also be considered as the displacement due to its proportional relationship to $\Delta L(t)$.

Table 1. Physical meaning of symbols in Equation (1)-(4)

Symbol	Physical meaning
t	Time index
p_0	Output intensity emitted by free running LD
$p(t)$	Laser output
m	Modulation index (typically $m \approx 10^{-3}$)
$\phi_0(t)$	Light phase of free running LD
$\phi_F(t)$	Light phase of LD with optical feedback
$g(t)$	Normalized laser output, also called SMI signal
C	Optical feedback level
α	Linewidth enhancement factor
L_0	Initial external cavity length
$\Delta L(t)$	Displacement of the external target
λ_0	Emitting wavelength of the free running LD

B. New algorithm

Supposing that the external target is in a periodical vibration, that is, $\Delta L(t)$ is periodic with a fundamental frequency of ω_0 . From Eq. (4), $\phi_0(t)$ is also periodic and can be expressed in the form of Fourier series as below:

$$\phi_0(t) \approx \frac{4\pi}{\lambda_0} L_0 + \sum_{k=1}^N [a_k \cos(k\omega_0 t) + b_k \sin(k\omega_0 t)] \quad (5)$$

where k is an integer number. N represents N th order Fourier series expansion. a_k and b_k are the coefficients in Fourier series.

Taking derivative on Eq. (5) with respect to time index t , we have:

$$\frac{d\phi_0(t)}{dt} = \omega_0 \sum_{k=1}^N [b_k k \cos(k\omega_0 t) - a_k k \sin(k\omega_0 t)] \quad (6)$$

Then taking derivative on Eq. (2) and Eq. (3), we have:

$$\frac{dg(t)}{dt} = \frac{d\phi_F(t)}{dt} [-\sin(\phi_F(t))] \quad (7)$$

$$\frac{d\phi_0(t)}{dt} = \frac{d\phi_F(t)}{dt} + C \frac{d\phi_F(t)}{dt} \cos[\phi_F(t) + \arctan(\alpha)] \quad (8)$$

Eq. (7) can be written as below:

$$\frac{d\phi_F(t)}{dt} = -\frac{dg(t)/dt}{\sin(\phi_F(t))}, \quad (\text{when } \sin(\phi_F(t)) \neq 0) \quad (9)$$

For the simplicity of illustration, we use $g'(t)$ to replace $dg(t)/dt$ in following.

Substituting Eqs. (6) and (9) into (8), we have:

$$\omega_0 \sum_{k=1}^N [b_k k \cos(k\omega_0 t) - a_k k \sin(k\omega_0 t)] = [1 + C \cos(\phi_F(t) + \arctan(\alpha))] \left(-\frac{g'(t)}{\sin(\phi_F(t))} \right) \quad (10)$$

as

$$\begin{aligned} \sin(\phi_F(t)) &= \begin{cases} +\sqrt{1 - \cos^2(\phi_F(t))} \\ -\sqrt{1 - \cos^2(\phi_F(t))} \end{cases} \\ &= \begin{cases} +\sqrt{1 - g^2(t)}, & \text{when } g'(t) < 0 \\ -\sqrt{1 - g^2(t)}, & \text{when } g'(t) > 0 \end{cases} \end{aligned} \quad (11)$$

Therefore, Eq. (10) can be written as:

$$\left\{ \begin{aligned} \omega_0 \sum_{k=1}^N [b_k k \cos(k\omega_0 t) - a_k k \sin(k\omega_0 t)] &= [1 + C \cos(\arctan(\alpha))g(t) - C \sin(\arctan(\alpha))\sqrt{1 - g^2(t)}] \left(-\frac{g'(t)}{\sqrt{1 - g^2(t)}} \right), \\ &\quad (\text{when } g'(t) < 0) \\ \omega_0 \sum_{k=1}^N [b_k k \cos(k\omega_0 t) - a_k k \sin(k\omega_0 t)] &= [1 + C \cos(\arctan(\alpha))g(t) - C \sin(\arctan(\alpha))(-\sqrt{1 - g^2(t)})] \left(-\frac{g'(t)}{(-\sqrt{1 - g^2(t)})} \right), \\ &\quad (\text{when } g'(t) > 0) \end{aligned} \right. \quad (12)$$

Re-arranging Eq. (12) yields the following:

$$\left\{ \begin{aligned} g'(t) &= -g'(t)g(t)u_1 + g'(t)\sqrt{1 - g^2(t)}u_2 \\ &\quad + \omega_0 \sqrt{1 - g^2(t)} \sum_{k=1}^N a_k k \sin(k\omega_0 t) - \omega_0 \sqrt{1 - g^2(t)} \sum_{k=1}^N b_k k \cos(k\omega_0 t), \quad (\text{when } g'(t) < 0) \\ g'(t) &= -g'(t)g(t)u_1 - g'(t)\sqrt{1 - g^2(t)}u_2 \\ &\quad - \omega_0 \sqrt{1 - g^2(t)} \sum_{k=1}^N a_k k \sin(k\omega_0 t) + \omega_0 \sqrt{1 - g^2(t)} \sum_{k=1}^N b_k k \cos(k\omega_0 t), \quad (\text{when } g'(t) > 0) \end{aligned} \right. \quad (13)$$

where

$$\begin{cases} u_1 = C \cos(\arctan(\alpha)) \\ u_2 = C \sin(\arctan(\alpha)) \end{cases} \quad (14)$$

From Eq. (14) we have:

$$\begin{cases} C = \sqrt{u_1^2 + u_2^2} \\ \alpha = \frac{u_2}{u_1} \end{cases} \quad (15)$$

In Eq. (13), $g(t)$ and $g'(t)$ are sample data (constant) at a certain time instance t obtained from an observed SMI signal. Other parameters, including u_1 , u_2 , a_k and b_k are to be estimated shown as below.

We introduce

$$\begin{aligned} G_1(t) &= g'(t)g(t) \\ G_2(t) &= g'(t)\sqrt{1 - g^2(t)} \\ G_3(t) &= g'(t) \\ A_k(t) &= \omega_0 \sqrt{1 - g^2(t)}k \sin(k\omega_0 t), \quad (\text{where } k = 1:N) \\ B_k(t) &= \omega_0 \sqrt{1 - g^2(t)}k \cos(k\omega_0 t), \quad (\text{where } k = 1:N) \end{aligned} \quad (16)$$

Note that ω_0 is treated as a known parameter, as it can be easily obtained by applying an auto-correlation operation on a piece of SMI signal [2]. Hence, the five quantities introduced in Eq. (16) are all constant at a certain time instance t . With the notation in Eq. (16), Eq. (13) can be written as follows:

17)

its corresponding derivative version $g'(t)$, enabling us to have the following:

(18)

selected based on the following:

1. The segment of SMI signal corresponding to a whole period of vibration usually consists of two regions corresponding to the increasing and decreasing part of the $\phi_0(t)$ respectively. $N+1$ data samples will be taken from the $g'(t) < 0$ region and the other $N+1$ samples will be from the $g'(t) > 0$ region (shown in Fig. 1).
2. Assuming that there are M fringes in $g'(t) < 0$ region in one segment of SMI signal, we set $N+1$ equally spaced levels over the fringe peak-to-peak height, yielding $N+1$ sample points within each individual $g'(t) < 0$ section.
3. Within each fringe, for the $g'(t) < 0$ section, $(N+1)/M$ samples are selected, resulting in total number of $N+1$ data samples distributed over the entire $g'(t) < 0$ region.
4. The other $N+1$ samples are selected in the same way from the region where $g'(t) > 0$.

same fringe number for both parts.

Fourier series, that is:

$$\begin{aligned}\phi_0(t) = & 8 \times \cos(2\pi \times 100t) + 2 \times \cos(4\pi \times 100t) \\ & + 1 \times \cos(6\pi \times 100t) + 0.5 \times \cos(8\pi \times 100t) \\ & + 8 \times \sin(2\pi \times 100t) + 2 \times \sin(4\pi \times 100t) \\ & + 1 \times \sin(6\pi \times 100t) + 0.5 \times \sin(8\pi \times 100t)\end{aligned}$$

we can use Eq. (15) to determine α and C .

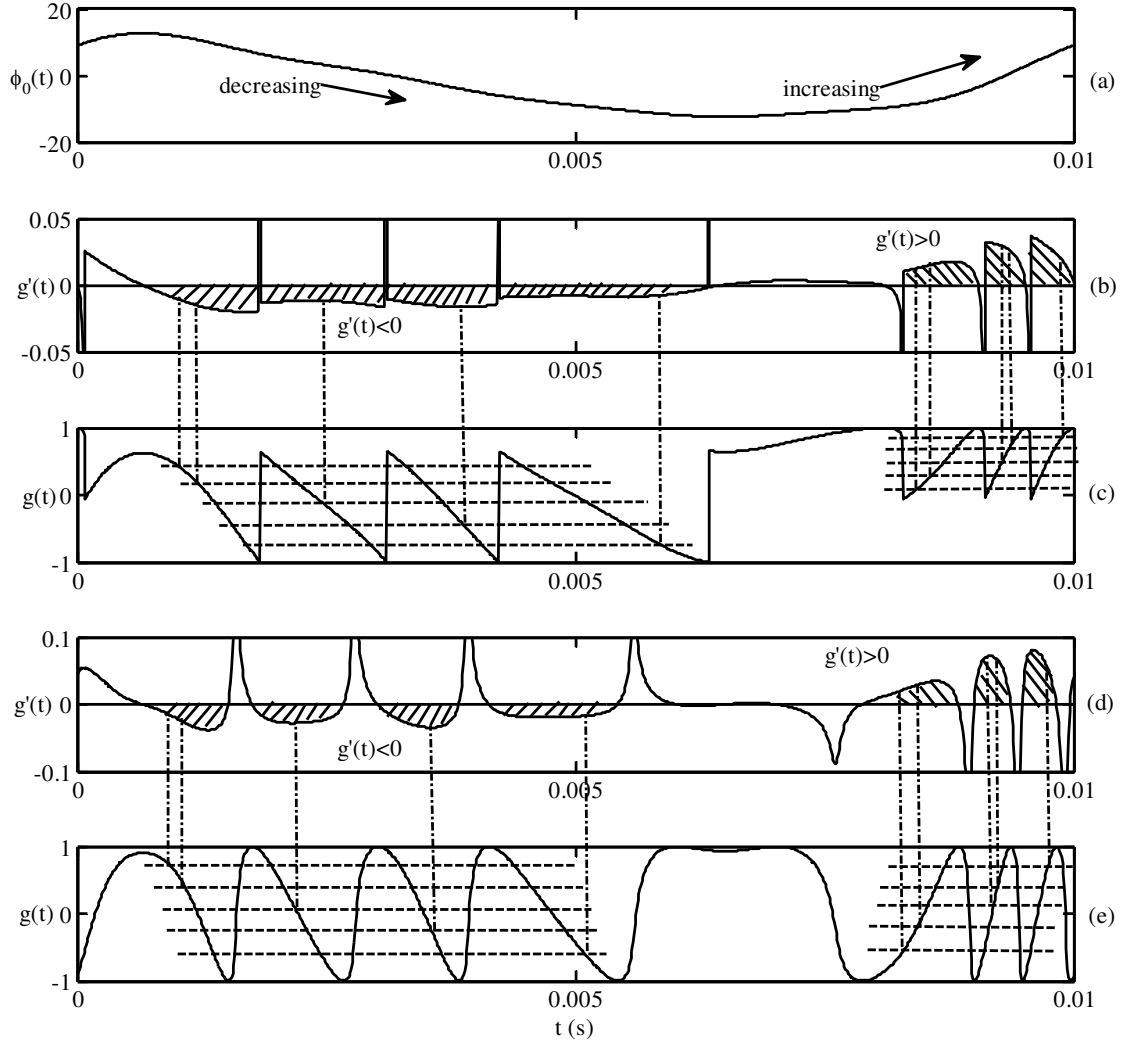


Fig. 1. Illustration of data selection. (a) phase $\phi_0(t)$ corresponds to a period of external vibration; (b) Derivative form ($g'(t)$) of the SMI signal $g(t)$ in (c); (c) A SMI signal $g(t)$ in moderate feedback regime; (d) Derivative form ($g'(t)$) of the SMI signal $g(t)$ in (e); (e) A SMI signal $g(t)$ in weak feedback regime;

3. Verification

A. Simulation

In order to verify the proposed algorithm, we firstly use the simulation data generated by the SMI model described in Eqs. (1)-(5) and apply the proposed algorithm on the data. We consider that the external target vibrates in a triangular form. Therefore, its corresponding $\phi_0(t)$ has a peak-to-peak amplitude of 60.000 (rad) and fundamental frequency of 100 Hz shown in Eq. (19).

$$\phi_0(t) = \begin{cases} 30 - \frac{60}{T_0}t, & \text{when } 0 \leq t < \frac{T_0}{2} \\ 30 + \frac{60}{T_0}t, & \text{when } \frac{T_0}{2} \leq t < T_0 \end{cases} \quad (19)$$

In general, the higher order of Fourier Series we use, the better reconstruction we can obtain. In this simulation, the Fourier expansion with 10th-order is sufficient to express a triangular vibration if there is no sharp change occurring on the movement. Hence, we expressed the $\phi_0(t)$ in Eq. (20):

$$\begin{aligned} \phi_0(t) \approx & 30 + 24.317 \cos(2\pi \times 100t) + 2.702 \cos(6\pi \times 100t) \\ & + 0.973 \cos(10\pi \times 100t) + 0.496 \cos(14\pi \times 100t) \\ & + 0.300 \cos(18\pi \times 100t) + 0.201 \cos(22\pi \times 100t) \\ & + 0.144 \cos(26\pi \times 100t) + 0.108 \cos(30\pi \times 100t) \\ & + 0.084 \cos(34\pi \times 100t) + 0.067 \cos(38\pi \times 100t) \end{aligned} \quad (20)$$

With the above $\phi_0(t)$ in Eq. (20) and based on Equations (2)-(5), two segments of SMI signals $g(t)$ are generated by incorporating two pairs of C and α with C/α as 0.800/3.000

and 5.000/5.000 respectively. Then the computer simulations are carried out according to the following:

Step 1: The fundamental angular frequency (ω_0) of the external vibration is estimated using the auto-correlation function of $g(t)$ [2];

Step 2: According to the selection rules presented in Section 2, $2N + 2$ data samples are selected respectively from a segment of an SMI signal $g(t)$ and its corresponding derivatives $g'(t)$. Then all the coefficients in Eq. (18) are determined using Eq. (16);

Step 3: Eq (18) is solved to yield the parameters including u_1 , u_2 and all Fourier coefficients $a_1 \cdots a_{10}$ and $b_1 \cdots b_{10}$;

Step 4: Eq. (15) is used to obtain C and α , and the vibration by Eq. (5) is reconstructed using the obtained coefficients.

The results of simulations are shown in Fig. 2, including $\phi_0(t)$, $g(t)$, the reconstructed vibration trace (denoted by $\tilde{\phi}_0(t)$) and the error associated with the estimation. It is seen that, for both of the two cases, $\tilde{\phi}_0(t)$ is very close to $\phi_0(t)$, with the error less than 0.11% and 0.006% respectively, thus giving an accurate estimation of the vibration trace. In addition, the two parameters C and α are also obtained with a reasonably high accuracy. For the case of $C/\alpha = 0.800/3.000$, we obtained C/α with the accuracy of 0.5% and 1.9% and in the situation of strong feedback $C/\alpha = 5.000/5.000$, we have obtained C/α with a accuracy of

0.06% and 0.12%. Note that the value in accuracy for parameters estimation is the relative standard deviation of the estimated results with respect to true parameter values in the simulation.

The results show that, the proposed method is able to measure vibration and all the parameters simultaneously with reasonable estimation accuracy, under different feedback regime (weak or strong), for a periodical vibration containing many harmonics.

B. Experiment

Experiments are also conducted to verify the effectiveness of the proposed method by means of the experimental SMI configuration illustrated in Fig. 3. A GaAlAs multi-quantum well (MQW) laser diode (LD) with module HL7851G from HITACHI is employed in our experiments. In the experiment, the LD is controlled by a laser controller (LDC2000) and a temperature controller (TEC200). We set the LD working at 140 mA (typical operating injection current) with an emitting wavelength of 785 nm and the operating temperature at 25°C. A loudspeaker is used to form the external cavity with the initial cavity length of 310 mm (L_0). The loudspeaker is driven by a sinusoidal signal of 80Hz and 6 Volt amplitude peak-to-peak. The vibrating target is kept unchanged through our experiments. Three experimental SMI signals with different optical feedback levels are obtained.

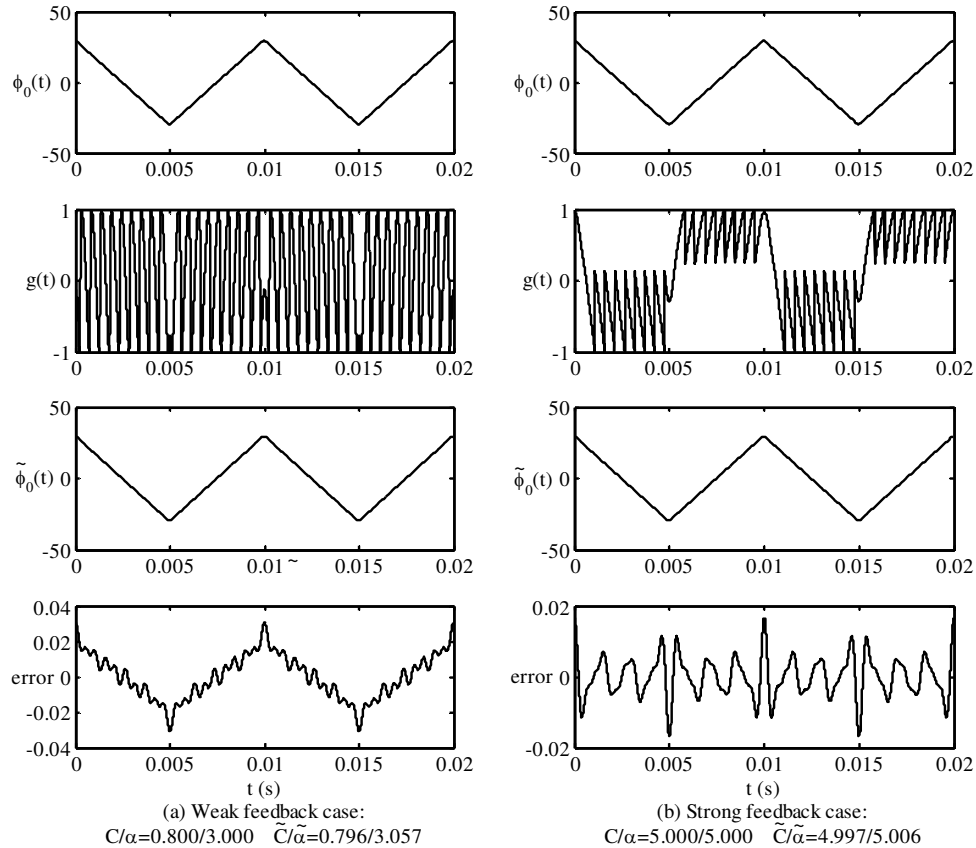


Fig. 2. Reconstruction results for triangular vibration. (a) reconstruction results for weak feedback regime with true values: $C/\alpha = 0.800/3.000$; (b) reconstruction results for strong feedback regime with true values: $C/\alpha = 5.000/5.000$.

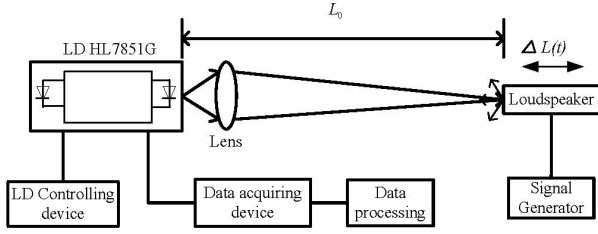


Fig. 3. SMI configuration

By considering 10-order Fourier extensions (it is enough to include the possible harmonics containing in the target vibration), we applied our algorithm on these further de-noised experimental signals using the method described in [16], then obtained parameters C , α and reconstructed the vibration of the loudspeaker. The results are shown in Fig. 4. The left column shows three SMI signals with different feedback levels. The right column shows the reconstructed vibration and the estimated values for C and α . It can be seen, firstly, the three reconstructed vibration are identical to each other as they correspond to same vibration. The magnitude of the vibration is with 1.83 μm in average. This value has been confirmed by

means of a commercial laser sensor LTC-025-04-SA from MTI instruments. The estimated values for both C and α are also confirmed by our previous method presented in [7].

4. Conclusion

In this paper, we propose an algorithm to simultaneously retrieve the vibration and multiple parameters associated with SLs using an SMI sensing system. In contrast to the existing work on SMI based vibration measurement, the proposed method does not require the knowledge the C and α , and in comparison with existing approaches for C and α measurement, the algorithm proposed does not need the detailed information on the movement trace of the object. Furthermore, the proposed method can work at any optical feedback regime. Therefore, the proposed algorithm lifts all the restrictions existed in SMI based sensing methods. Also, simple and low computation makes it easy to be implemented in practice. Both computer simulations and experiment have been used to verify the proposed algorithm, showing that the vibration, the optical feedback level and the alpha factor can be effectively estimated.

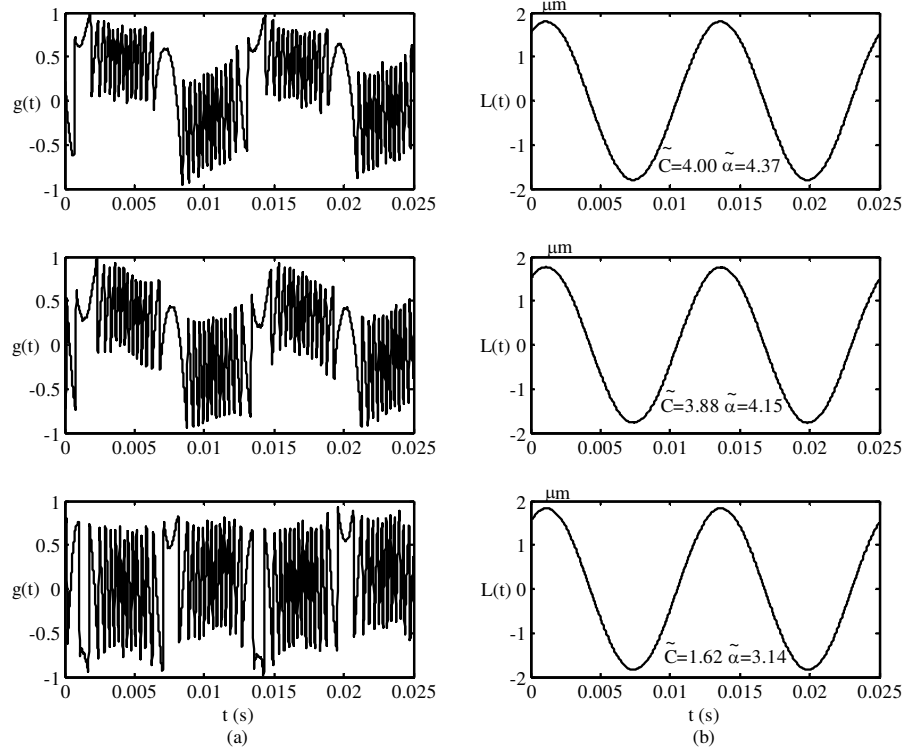


Fig. 4. Vibration reconstruction and parameters estimation results by using experimental data. (a) three SMI signals under different optical feedback regime; (b) vibration reconstruction and parameter estimation results

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